



## IN THE UNITED STATES ATENT AND TRADEMARK OFFICE

In re the Application of:

Jung-hyun LEE, et al.

Art Unit: 2822

Serial No. 10/617,767

Examiner: J.B. Vockrodt

Filed: July 14, 2003

Confirmation No. 4046

For: Deposition Method of a Dielectric Layer

Attorney Docket No.: 249/349

## AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Non-Fee Amendment Commissioner for Patents United States Patent and Trademark Office P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **INTRODUCTORY COMMENTS**

In response to the Office action mailed March 18, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of claims, which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.